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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/303,855 11/26/2002 PAT 6,720,250

EC

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-366938 11/30/2001

EC

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/26/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>Eric Chun</i> Initials <i>EC</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 1
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## TITLE

Slurry for chemical mechanical polishing for copper and method of manufacturing semiconductor device using the slurry

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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